

Notice of References Cited	Application/Control No. 10/754,291		Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Jae U. Yu		Art Unit 2185	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-2003/0188114	10-2003	Lubbers et al.	711/162
*	C	US-2004/0210731	10-2004	Chatterjee et al.	711/165
*	D	US-2003/0051111	03-2003	Nakano et al.	711/162
*	E	US-6,816,951	11-2004	Kimura et al.	711/162
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	M	US-			

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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